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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(213.002-D1-US)

APPLICANT: Ye et al.

FILED: August 22, 2003

SERIAL NO.: 10/646,313

APR 15 2004

TITLE: System and Method for Lithography Process Monitoring  
And Control

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**RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED**

1. Second Information Disclosure Statement (1 page + 1 sheet of  
Modified Form PTO-1449 + Reference cited therein)

DATE: April 12, 2004

[Check No. N/A]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 213.002-D1-US)

In the Application of: **Ye et al.**

Serial No: **10/646,313**

Filed: **August 22, 2003**

Title: **SYSTEM AND METHOD FOR LITHOGRAPHY  
PROCESS MONITORING AND CONTROL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

) Group Art Unit:

) Before Examiner

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 12, 2004

Date

Michiko Sato  
(person signing this certificate)

Neil A. Steinberg  
Signature

**SECOND INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

Submitted herewith is one (1) sheet of a modified Form PTO-1449. A copy of the document cited on the attached Form PTO-1449 is also submitted.

It is respectfully requested that the Examiner make his/her consideration of the document formally of record with the initial Office Action.

Respectfully submitted,

Date: April 12, 2004

Neil A. Steinberg  
Neil A. Steinberg  
Reg. No. 34,735  
650-968-8079

PTO-1449 (Modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 213.002-D1-US	Sheet 1 of 1 SERIAL NUMBER 10/648,313
	APPLICANT(S) Ye et al.	
	FILING DATE August 22, 2003	GROUP ART UNIT

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Kodak KAI-1100M Kodak KAI-11000CM Image Sensor, Device Performance Specification, Revision 3.0, June 2, 2003, 42 pages

EXAMINER	DATE CONSIDERED
EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.	